

DOCKET NO.: 213876US-10944-8863-2-PCT

IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF :  
NAOMASA SHIRAISHI : ATTN: APPLICATION DIVISION  
SERIAL NO: 09/926,149 :  
FILED: SEPTEMBER 12, 2001 :  
FOR: EXPOSURE APPARATUS AND :  
EXPOSURE METHOD, AND DEVICE  
MANUFACTURING METHOD

8/A  
3/5/03  
M. Pradgen

PRELIMINARY AMENDMENT

ASSISTANT COMMISSIONER FOR PATENTS  
WASHINGTON, D.C. 20231

SIR:

Prior to a first examination on the merits, please amend the above-identified  
application as follows:

IN THE TITLE

Please delete the title and replace with the following title:

EXPOSURE DEVICE, EXPOSURE METHOD, AND DEVICE  
MANUFACTURING METHOD

A/

IN THE CLAIMS

Please amend the below-noted claims to read as follows:<sup>1</sup>

<sup>1</sup> A marked-up copy of the amendments is attached hereto.